

Form PTO-1449

Docket Number (Optional)

Application Number

TSMC, -01-353

10/058,474

Applicant

Hsiu-Chu Lin et al.

Filing Date

01/28/02

Group Art Unit

2161

INFORMATION DISCLOSURE CITATION
ON AN APPLICATION

APR 08 2042 (Several shoots if necessary)

U. S. PATENT DOCUMENTS

[illegible]

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APR 09 2002

Technology Center 2100

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)

~~EXAMINER~~

Shannon Sawo

DATE CONSIDERED

12-19-05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.